University of Iowa Microfabrication Facility (UIMF)
User Fees 2015-2016 (Academic and External rates)

Wet-Processing and Metrology Lab (IATL170)

$ 30/hr: any tools excluding Oxidation furnace
$ 15/hr: wet bench
$30/day: Oxidation furnace

Thin Film, Etching and Nanoimprint Lab (IATL 174)

Cleanroom usage only: $ 25/hr.
Cleanroom access fee: $ 25/day (unlimited access for the day).
Rate on any tools: $ 50/hr.
Rate on wet bench: $15/hr.

Electron Beam (E-Beam) Nanolithography (IATL 172)

Cleanroom usage only: $ 25/hr.
Cleanroom access fee: $ 25/day (unlimited access for the day).
E-Beam Lithography: $ 70/hr.

Important Notes:
* Users who book tools in either IATL 172 or 174 will be automatically charged the cleanroom access fee.
* Users will be charged the cleanroom access fee once, for booking tools in 172 and 174 on the same day.
* Any tool booked is charged in 30 min. increment and is the minimum charge.
* Users will NOT be charged for simply swiping their card to access IATL 172 and 174 to collect items.
* External academic users and UI affiliated companies will follow the same above charge model.
* External industrial users will be charged at twice the academic rates.

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